

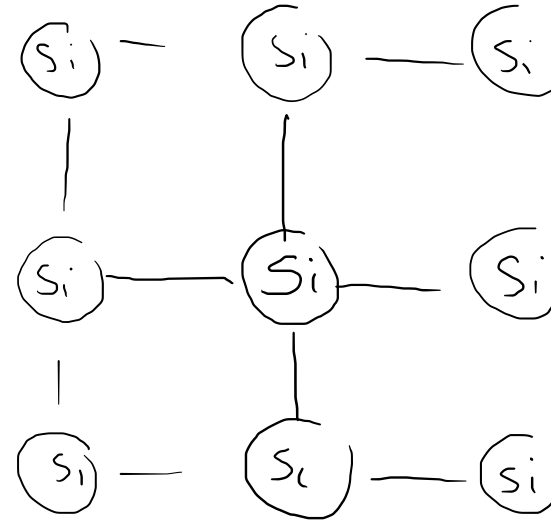
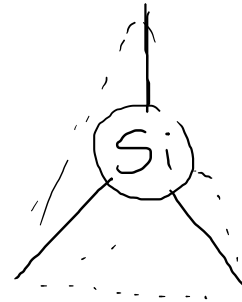
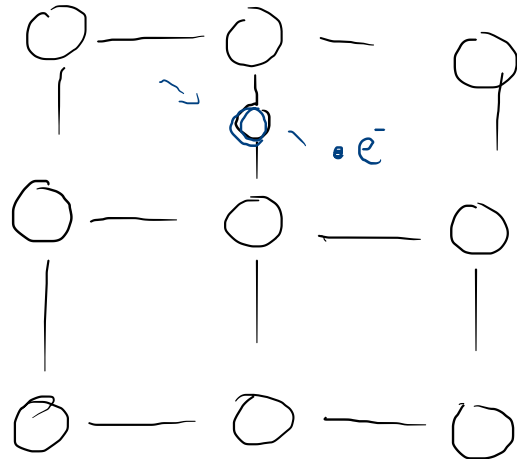
SEMICONDUCTORI

Si Ge ~ 90°C
 ~ 200°C

GaAs

Si 1h e⁻

28 — 1h p
 — 1h n



$$\mu_e \gg \mu_L$$

μ
 MV

$$\mu_{Si_e} = 1500 \left[\frac{\text{cm}^2}{\text{V.s}} \right]$$

$$\mu_{Si_L} \cong 475$$

$$n_i(\tau) \equiv p_i(\tau) \cong 1,5 \cdot 10^{10} \left[\frac{1}{\text{cm}^3} \right]$$

PURO o INTRINSECO $5 \cdot 10^{27}$

$$G_{Si} = n_i q \mu_n + P_i \cdot q \cdot \mu_p$$